

A 40-GHz-Bandwidth, 4-Bit, Time-Interleaved A/D Converter Using Photoconductive Sampling

Lalitkumar Y. Nathawad, *Student Member, IEEE*, Ryohei Urata, *Student Member, IEEE*,
Bruce A. Wooley, *Fellow, IEEE*, and David A. B. Miller, *Fellow, IEEE*

Abstract—GaAs photoconductive switches have been integrated with two parallel 4-bit CMOS analog-to-digital (A/D) converter channels to demonstrate the time-interleaved sampling of wide-band signals. The picosecond sampling aperture provided by low-temperature-grown-GaAs metal-semiconductor-metal switches, in combination with low-jitter short-pulse lasers, enables the optically-triggered sampling of electrical signals with tens of gigahertz bandwidth at low to medium resolution. A pair of parallel sampling paths, one for sampling and the second for feedthrough cancellation, generate a differential held signal that is quantized by a low-input capacitance, high-speed flash A/D converter. Dynamic offset averaging is employed to improve converter linearity. An experimental time-interleaved two-channel A/D converter provides about 3.5 effective bits of resolution for inputs up to 40 GHz when tested at an optically-triggered sampling rate of 160 MHz. The sampling rate was limited by the available optical source. Each A/D converter channel operates up to a 640-MHz conversion rate, dissipates 70 mW of power, and occupies an area of $150\ \mu\text{m} \times 450\ \mu\text{m}$ in a 2.5-V, 0.25- μm CMOS technology.

Index Terms—Analog-to-digital (A/D) conversion, CMOS analog integrated circuits, flash converter, low-temperature-grown GaAs, metal-semiconductor-metal (MSM) devices, offset averaging, optical data processing, resistor averaging network, sample and hold, transconductance amplifiers.

I. INTRODUCTION

HIGH-SPEED analog-to-digital (A/D) converters capable of digitizing signals with bandwidths of several tens of gigahertz have applications in optical communications, wideband radar, and high-speed instrumentation. In fiber-optic communications, dispersion effects that limit the length of the fiber link may be corrected with digital equalization techniques if A/D converters capable of conversion rates as high as 10–40 GHz are available [1]. Test instruments, such as wideband digitizing oscilloscopes, continually demand A/D converters with increased sampling rates and greater input bandwidth. Although the time interleaving of many parallel electronic A/D converters can enable very high aggregate conversion rates [2], the effective resolution of the converter at high input frequencies remains limited by the bandwidth and aperture jitter of the input sample-and-hold circuit. As illustrated in

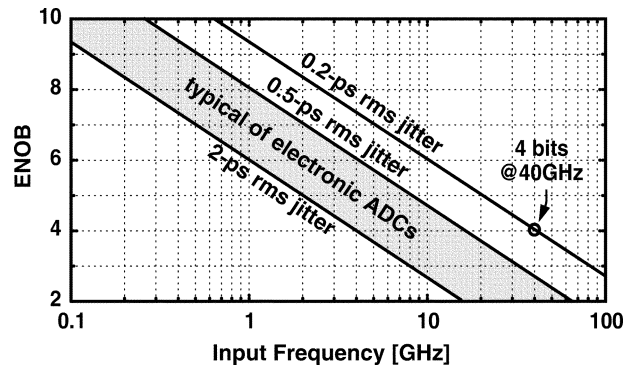


Fig. 1. ENOB of resolution versus input frequency, for varying aperture jitter.

Fig. 1, the effective number of bits (ENOB) of resolution that can be achieved for a given rms aperture jitter decreases logarithmically with input frequency. Aperture jitter in the 0.5–2-ps range is typical for high-performance electronic A/D converters [3], whereas an aperture jitter of less than 0.2 ps is needed to achieve 4 effective bits of resolution at a 40-GHz input frequency.

A number of photonic sampling techniques have been proposed to overcome the limited input bandwidth and timing jitter of electronic sampling circuits [4]. These photonic techniques are enabled by mode-locked laser technology that is capable of generating periodic optical pulses with subpicosecond pulse widths and timing jitter of tens of femtoseconds. Many of the proposed photonic A/D converters involve modulating a short-pulse optical source with the input electrical signal and optically demultiplexing the modulated pulses to a number of parallel photodetectors and electronic A/D converters. The design of these systems is complicated by the need to optically demultiplex to a large number of channels in order to achieve a high aggregate sampling rate. Alternative approaches to photonic A/D conversion, such as the one proposed herein, involve sampling the electrical input with a number of parallel photoconductors that are optically triggered in sequence by time-interleaved optical pulses. Photoconductive switches with picosecond response times enable a wide input bandwidth, but generally provide poor isolation between the input and sampled signal due to capacitive coupling.

This paper introduces a parallel A/D conversion architecture, shown in Fig. 2, wherein a large number of time-interleaved photonic sampling channels each feed a 4-bit CMOS A/D converter. Integration of the photonic sampling switches with the CMOS A/D converter circuitry allows for the small hold capacitance needed to achieve a sufficiently large sample-and-hold

Manuscript received April 10, 2003; revised July 7, 2003. This work was supported in part by the Defense Advanced Research Projects Agency under Contract DAAD17-99-C-0048, and in part by Matsushita Corporation and the Stanford Graduate Fellowship program.

L. Y. Nathawad and B. A. Wooley are with the Center for Integrated Systems, Stanford University, Stanford, CA 94305-4070 USA (e-mail: nathawad@par.stanford.edu).

R. Urata and D. A. B. Miller are with the E. L. Ginzton Laboratory, Stanford University, Stanford, CA 94305 USA.

Digital Object Identifier 10.1109/JSSC.2003.819172

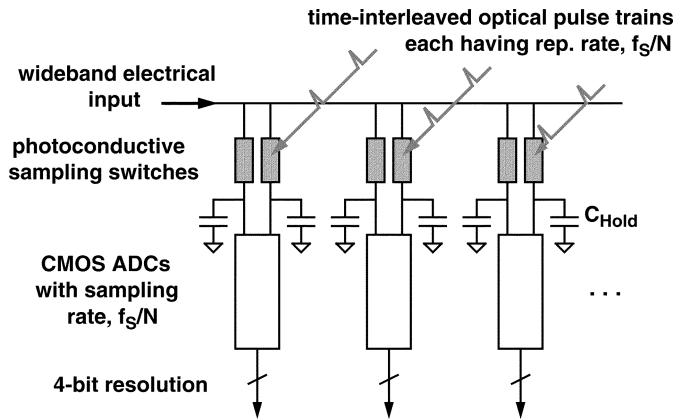


Fig. 2. Proposed time-interleaved photonic A/D converter architecture with per-channel sampling rate f_S/N , where f_S is the aggregate sampling rate and N is the number of channels.

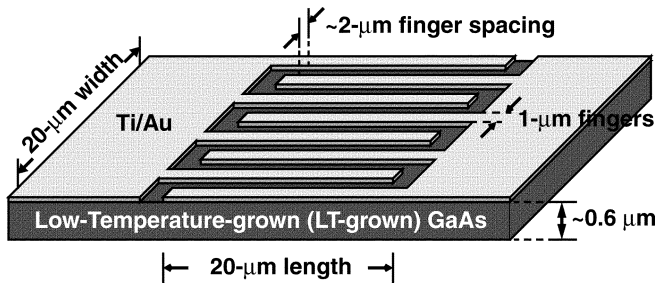


Fig. 3. Photoconductive sampling switch consisting of an 8-finger, $20\ \mu\text{m} \times 20\ \mu\text{m}$ area, interdigitated MSM structure.

output voltage. Section II describes the photonic sampling technique that uses optically-triggered, low-temperature (LT)-grown GaAs switches [5] to achieve an input bandwidth of more than 40 GHz. The proposed A/D converter architecture and circuit implementation are detailed in Section III and IV. Constraints imposed by the photonic sampling switches dictate trade-offs among the input capacitance, linearity, common-mode rejection, sampling rate and resolution of the A/D converters. Additional considerations of circuit area and power ultimately led to a compact, high-speed 4-bit flash A/D converter design. An experimental prototype two-channel A/D converter was fabricated in a 2.5-V, $0.25\text{-}\mu\text{m}$ CMOS technology and integrated with LT-grown GaAs switches using a flip-chip bonding technique. Each A/D converter channel occupies an area of $150\ \mu\text{m} \times 450\ \mu\text{m}$ and dissipates 70 mW at a sampling rate of 640 MHz. The prototype provides 3.5 effective bits of resolution across a 40-GHz input frequency range, at an optically-triggered sampling rate of 160 MHz. Section V describes the experimental test setup and summarizes the measured performance.

II. PHOTONIC SAMPLING

The proposed photonic sample-and-hold is comprised of a LT-grown GaAs metal-semiconductor-metal (MSM) switch that is optically triggered to sample an electrical input signal onto a small hold capacitance [6]. The switch is fabricated by molecular beam epitaxy of GaAs on a semi-insulating GaAs wafer at the relatively low substrate temperature of 250°C ,

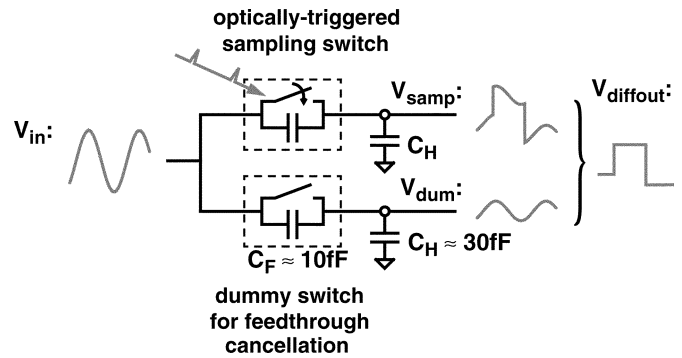


Fig. 4. Optically-triggered sample-and-hold with a replica dummy switch for feedthrough cancellation.

followed by a 1-min, 700°C rapid thermal anneal. The low epitaxial growth temperature and subsequent anneal lead to the incorporation of excess As atoms in the GaAs crystal lattice, resulting in a material with short carrier lifetimes of only a few picoseconds and high resistivity except when illuminated [5]. A titanium/gold contact metal is deposited on the LT-grown GaAs and patterned to form an interdigitated 8-finger, $2\text{-}\mu\text{m}$ finger-spacing MSM device, as illustrated in Fig. 3. The $20\ \mu\text{m} \times 20\ \mu\text{m}$ area of the MSM switch is roughly equal to the spot size of the illuminating optical beam. For integration with the CMOS A/D converter circuits, the MSM switch is attached to the CMOS chip using flip-chip bonding, and the GaAs substrate is subsequently etched away to allow back-side illumination of the MSM switch. The output of the switch drives a hold capacitance, C_H , of approximately 30 fF that is composed entirely of parasitic capacitance associated with the flip-chip bonding pad and the CMOS A/D converter input. Such a small hold capacitance is necessary because of the limited drive capability of the photoconductive switch.

Sampling of the electrical input is optically triggered with a mode-locked laser generating 150-fs wide optical pulses. The incident light is absorbed in the LT-grown GaAs, thus generating excess electron-hole pairs that enable conduction between the terminals of the switch. These carriers are trapped within a few picoseconds after the light is removed, providing a very fast switch turn-off. Electrooptic-sampling measurements of the impulse response of these types of MSM switches demonstrate a 1.5-ps full-width half-maximum (FWHM) output signal [6]. Owing to its single-crystal structure, LT-grown GaAs also exhibits reasonably high carrier mobility, which helps reduce the on-resistance of the switch. The switch provides an on-resistance of $R_{\text{ON}} < 100\ \Omega$ and an off-resistance of $R_{\text{OFF}} > 100\ \text{M}\Omega$. However, it exhibits a relatively large feedthrough capacitance, C_f , of approximately 10 fF. As a result, a large feedthrough signal is superimposed on the held voltage when the switch is in the off state.

Shown in Fig. 4 is the schematic of an optically-triggered sample-and-hold circuit employing replica feedthrough cancellation. The electrical input signal is sampled using a pair of MSM switches, of which only one is optically triggered to sample the input signal onto the hold capacitance. The second (dummy) switch provides a replica of the feedthrough signal that is subsequently subtracted from the sampled signal at

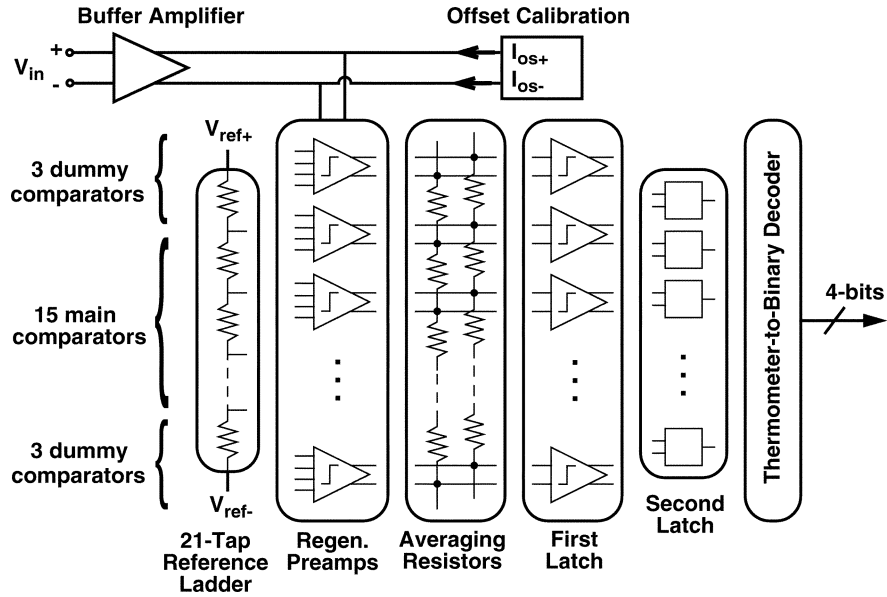


Fig. 5. Block diagram of the CMOS A/D converter.

the differential input of the CMOS A/D converter. To avoid hysteresis (memory of the previous sample), the optically sampled output, V_{samp} , is reset by the CMOS input circuit prior to sampling, as explained in Section IV-A.

If it is assumed that the input is optically sampled at time, T_k , the differential output of the sample-and-hold circuit is

$$V_{\text{diffout}}(t) = V_{\text{samp}}(t) - V_{\text{dum}}(t) = (1 - f) \cdot V_{\text{in}}(T_k) \quad (1)$$

where f is the capacitive feedthrough ratio

$$f = \frac{C_f}{C_f + C_H}. \quad (2)$$

Capacitive feedthrough is effectively eliminated at the cost of reduced output amplitude. In practice, mismatch between the two MSM switches as well as between the hold capacitances, limits the degree of feedthrough cancellation and may ultimately limit the resolution that can be achieved. The switches used in this work achieve sufficient matching for 4-bit resolution with typically less than 2% residual feedthrough in the differential output.

The finite R_{OFF} of the dummy MSM switch in parallel with C_f and in series with C_H forms a low-pass filter that passes the dc input voltage level to the dummy output, V_{dum} , but also limits operation of the sample-and-hold to input frequencies well above $1/(2\pi R_{\text{OFF}} C_f)$. At lower input frequencies, the switch feedthrough is no longer predominantly capacitive and the resistive feedthrough of the dummy switch attenuates the differential output signal.

III. TIME-INTERLEAVED PHOTONIC A/D CONVERTER ARCHITECTURE

The photonic sample-and-hold circuit described in the previous section is capable of operating at sampling rates of tens of gigahertz. However, it is difficult to design a single-path A/D converter capable of digitizing the held sample at these rates. Alternatively, a highly parallel photonic A/D converter

architecture, shown in Fig. 2, is proposed wherein an electrical input is sampled by a large number of time-interleaved channels to achieve a high aggregate sampling rate, f_S . Each channel consists of an optically-triggered MSM sample-and-hold circuit feeding a 4-bit CMOS A/D converter operating at a per-channel sampling rate, f_S/N , where N is the number of time-interleaved channels. The output of a mode-locked laser generating sub-picosecond wide pulses with repetition rate, f_S/N , is split into N beams, each with a different time delay, to drive the time-interleaved photonic sampling switches in succession. The optical pulses can be time-interleaved using free-space optics by introducing appropriate delay paths for each beam without significant attenuation or dispersion of the optical pulse. In free space, a 1-ps delay corresponds to an optical path length of 300 μm . Path length differences can be controlled to within a few microns, corresponding to timing skews of less than 10 fs. The use of optically-triggered sampling and time-interleaving greatly relaxes the jitter and timing skew requirements for the electrical clock signals driving the CMOS A/D converters, as well as the input bandwidth required of these converters.

The CMOS A/D converter used to digitize the sampled signals in the proposed system is constrained by the need for a very low input capacitance, as well as the low power dissipation and small area that are needed to allow the integration of many converters on a single chip. Achieving more than 6 to 8 bits of resolution is unlikely with this photonic sampling architecture because of mismatch in the replica-based feedthrough cancellation. For resolutions below 8 bits, flash A/D converter architectures generally provide the highest sampling rate per unit of power dissipated, as well as the highest sampling rate per unit area. However, the input capacitance, power, and area of a flash A/D converter scale exponentially with resolution. Another factor influencing the CMOS A/D converter design is time-interleaving errors [7] such as gain and offset mismatch among the parallel paths, which can generate objectionable tones in the output spectrum. Given these constraints, a 4-bit resolution, 640-MSample/s CMOS A/D converter was chosen

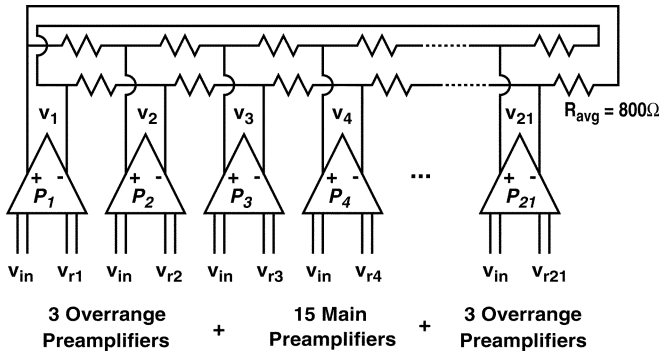


Fig. 8. Implementation of resistive offset averaging of preamplifier array outputs.

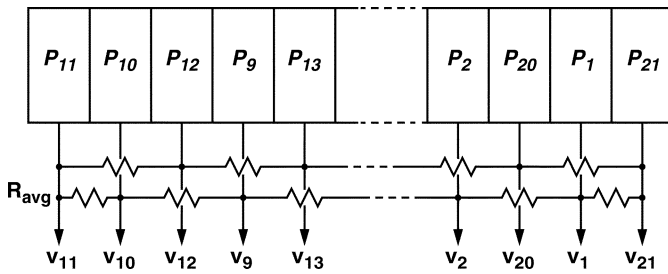


Fig. 9. Layout of preamplifier array with averaging resistor network (for simplicity, only single-ended outputs are shown).

inputs. The complementary outputs of the first and last overrange preamplifiers are cross-connected through a pair of averaging resistors so that every preamplifier in the array sees the same effective load impedance and has a balanced number of preamplifiers contributing to its output.

In general, the added overrange preamplifiers reduce the input range available to the main preamplifier array, thus reducing the maximum quantization step size that can be used. However, in this design the linearity of the buffer amplifier already limits the quantization step size, so the input range of the main preamplifier array is unaffected by the presence of overrange preamplifiers. The addition of the overrange preamplifiers does increase the input capacitance and power dissipation. Ref. [13] suggests an averaging termination technique that may be used to reduce the number of overrange amplifiers in a conventional resistor-loaded preamplifier array, but the approach is difficult to apply to a regenerative implementation.

If the preamplifier array shown schematically in Fig. 8 was laid out sequentially, a pair of long interconnects would be needed to connect the ends of the preamplifier array. To avoid the large parasitic capacitance and resistance that would be introduced by such an interconnect, the preamplifier array is laid out in a single interleaved row as shown in Fig. 9. With this layout pattern, all adjacent preamplifiers (e.g. P_k and P_{k+1}) are at most 2 cell widths apart.

The value of R_{avg} was chosen to minimize the net input-referred offset, $\sigma_{os,total}$, due to preamplifier offset, $\sigma_{os,pa}$, and offset in the subsequent comparator, $\sigma_{os,comp}$. A small R_{avg} improves averaging of preamplifier offsets at the expense of less preamplifier gain, G_{pa} , resulting in a greater input-referred

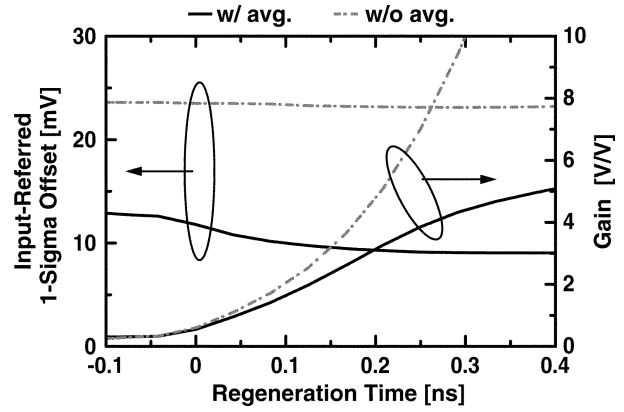


Fig. 10. Simulated preamplifier offset and gain versus regeneration time with and without resistor averaging.

offset contribution from the comparator. If the preamplifier and comparator offsets are independent random variables, then

$$\sigma_{os,total} = \sqrt{\sigma_{os,pa}^2(R_{avg}) + \left(\frac{\sigma_{os,comp}}{G_{pa}(R_{avg})}\right)^2} \quad (4)$$

Fig. 10 shows the results of Monte Carlo simulations of the preamplifier offset and gain as functions of regeneration time, without averaging and with $R_{avg} = 800 \Omega$. The time at which the clock signal crosses $V_{DD}/2$ is defined as $t = 0$. Without averaging, the preamplifier offset remains constant and the gain increases exponentially, as expected. However, with averaging, the preamplifier input-referred offset is greatly reduced and decreases further as the output regenerates, but gain is also reduced because the averaging resistors load the outputs. In the reset phase, the preamplifier has a differential voltage gain of about 0.3 and provides 3-GHz of bandwidth with an effective load resistance, $R_{L,reset} \approx 800 \Omega$. The low $R_{L,reset}/R_{avg}$ ratio results in a moderate factor of 1.8 offset reduction. During the regeneration phase, the preamplifier offset is dynamically averaged with an effective $R_{L,regen} \approx -2 \text{ k}\Omega$. If a preamplifier output regenerates toward a voltage level that is not halfway between the outputs of the adjacent preamplifiers, then the averaging resistors pull the output back toward the middle. As the outputs grow larger, so does the current in the averaging resistor network, eventually limiting the preamplifier gain that may be obtained. After a 250-ps regeneration time, the preamplifier offset is reduced by a factor of 2.6, but the voltage gain is also reduced from 7 to 4 when compared to the preamplifiers without averaging.

D. First and Second Latch

A two-stage latch follows the preamplifier to provide additional regenerative gain. The first stage, shown in Fig. 11, is a low-offset, low-output-swing latch that is biased with a constant current. The first latch maintains a constant output common-mode level during the reset and regeneration phases, which helps to reduce any input-referred offset due to mismatch in the output capacitive loads. An NMOS transistor, M_0 , clamps the output voltage swing for fast overdrive recovery. M_0 is biased in cutoff to minimize loading of the output nodes except in the presence of large output swings.

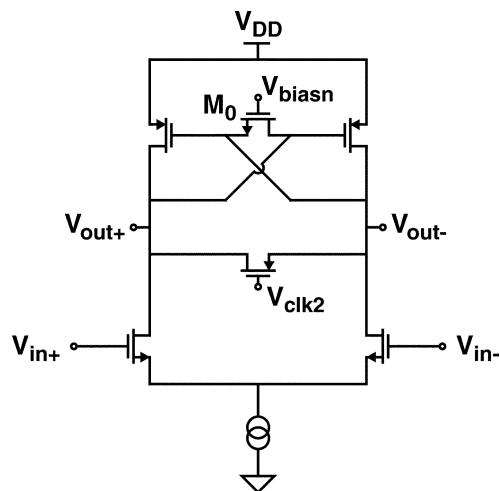


Fig. 11. First-stage low-offset latch with NMOS clamp.

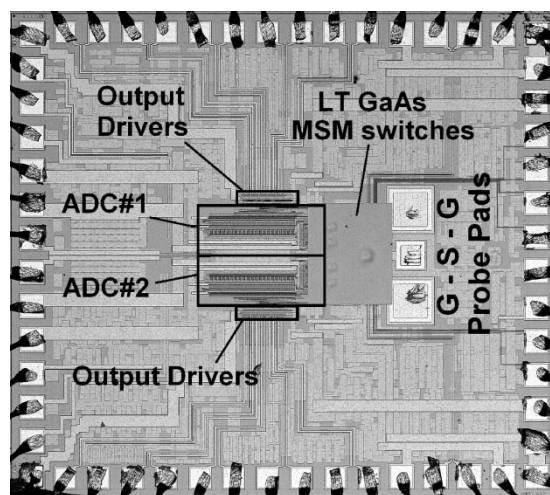


Fig. 13. Chip micrograph of prototype two-channel photonic A/D converter.

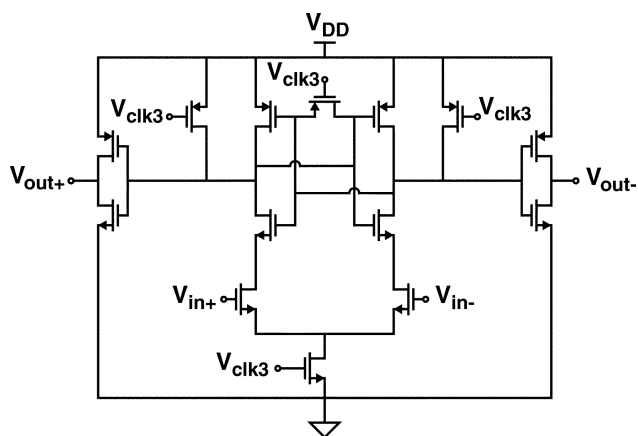


Fig. 12. Second-stage differential edge-triggered latch with CMOS output voltage levels.

The output of the first latch is fed to a second differential edge-triggered latch [14], shown in Fig. 12, that amplifies its input to CMOS voltage levels. The array of latches provide a thermometer code output that drives a 4-bit ROM to generate the corresponding binary output code.

V. EXPERIMENTAL RESULTS

Shown in Fig. 13 is a die micrograph of a prototype two-channel A/D converter fabricated in a 0.25- μm CMOS technology. The LT-grown GaAs MSM switches have been integrated with the CMOS chip using flip-chip bonding. Each A/D converter channel occupies a 150 μm \times 450 μm area and consumes about 70 mW of power, not including output drivers, at a sampling rate of 640 MSample/s. The electrical input signal is driven directly onto the chip using a ground-signal-ground (G-S-G) coplanar microwave probe to avoid package parasitics and terminated on-chip with a 50- Ω polysilicon resistor. The digital outputs of the A/D converter are buffered and driven off chip using differential current-mode signaling with an off-chip termination resistance of 150 Ω . The output drivers consist of open-drain NMOS differential pairs biased with a constant tail current in order to minimize digital switching noise.

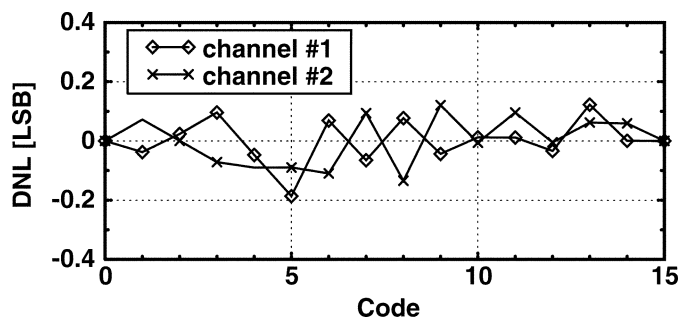


Fig. 14. Measured DNL of each CMOS A/D converter at 640 MS/s.

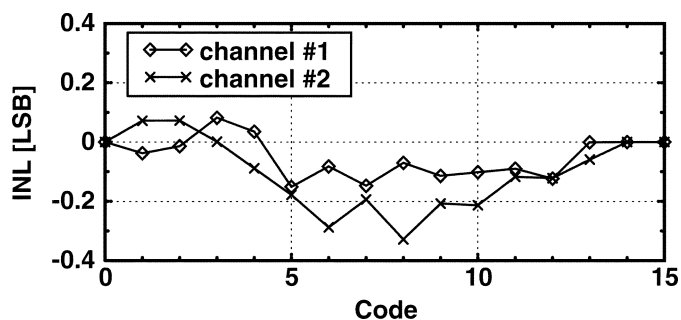


Fig. 15. Measured INL of each CMOS A/D converter at 640 MS/s.

Static mismatch between the two A/D converter channels and linearity errors in each of the channels were measured with a low-frequency signal applied directly to the CMOS A/D converter inputs through small NMOS pass-transistors. The measured gain mismatch of the two channels was 1.5%, and the offset mismatch before and after calibration were 62 mV (0.62 LSB) and <2 mV (0.02 LSB), respectively. The DNL and integral nonlinearity (INL) of each A/D channel were measured for a 2.5-MHz input signal and a 640-MHz conversion rate using the code density test [15]. As shown in Fig. 14 and Fig. 15, the prototype has a peak DNL and INL of 0.2 LSB and 0.35 LSB, respectively.

Fig. 16 illustrates the test setup used to evaluate the performance of the A/D converter with optically-triggered sampling. An 850-nm titanium/sapphire mode-locked laser generates 150-fs wide optical pulses at an 80-MHz repetition rate. The

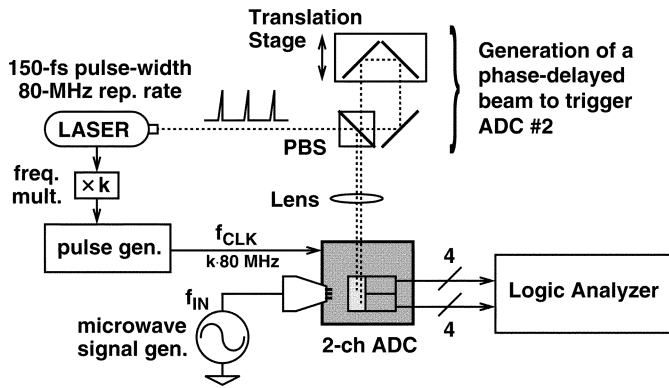


Fig. 16. Setup for testing the prototype time-interleaved two-channel A/D converter.

output of the laser is split into two beams using a polarization beam splitter (PBS). The vertical polarization is reflected by the PBS and focused onto the MSM sampling switch of A/D converter channel #1, whereas the horizontal polarization is transmitted through the PBS and appropriately delayed with mirrors and a micrometer-precision translation stage before being focused onto the MSM sampling switch of A/D converter channel #2. The relative delay of the two optical beams can be adjusted to about 6-fs precision by varying the optical path length in 2- μm steps. An optical power of about 4 mW per channel, corresponding to a pulse energy of 50 pJ, is required to activate the MSM switch and fully charge the hold capacitance. The CMOS A/D converters are driven by an electrical clock at frequency f_{CLK} , generated with a pulse generator that is phase-locked to the laser. The pulse generator allows 1-ps delay adjustments in f_{CLK} that are used to align the CMOS A/D converter timing with the optical sampling pulses. A 40-GHz microwave signal generator provides the high frequency input signal and the digital outputs of the A/D converter are captured with a logic analyzer.

The test setup was limited to an optically-triggered sampling rate of 80 MHz per channel by the available laser. However, operation of the A/D converter was demonstrated at higher conversion rates by using an f_{CLK} that is a multiple, k , of 80 MHz. A higher f_{CLK} reduces the time available for quantization and stresses A/D converter operation. Since the input signal is optically sampled at an 80-MHz rate, only every k th digital output of the A/D converter is valid, and the intermediate $k - 1$ outputs are discarded in software. Although scaling f_{CLK} demonstrates the potential for higher frequency operation, this test may fail to capture hysteresis in the A/D converter that may occur at higher optical sampling rates. However, since the sampled input to the CMOS A/D converter is reset prior to each conversion cycle, significant hysteresis is not expected.

The A/D converter's dynamic performance was evaluated by taking the fast Fourier transform (FFT) of the digital output when a single tone is applied to the input of the converter. Fig. 17 illustrates the dominant distortion tones in the output spectrum obtained by taking the 8192-point FFT of the A/D converter outputs when sampling a 40-GHz input tone at a sampling rate of $f_s \approx 160$ MS/s. Undersampling, that is sampling below the Nyquist rate, causes the input tone and all of its harmonics to

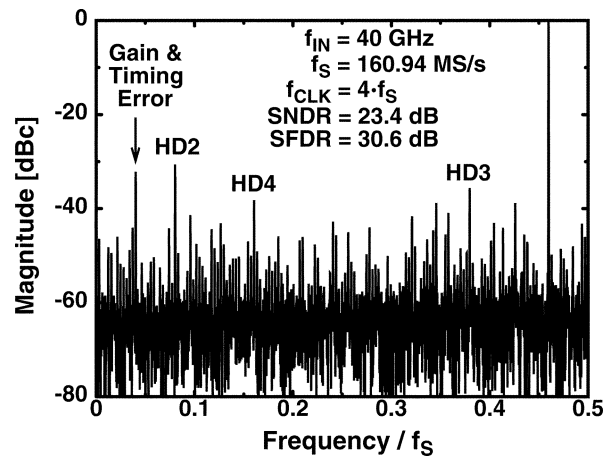


Fig. 17. Output spectrum (8192-point FFT) of the time-interleaved two-channel A/D converter with $f_s \approx 160$ MS/s and $f_{\text{IN}} = 40$ GHz.

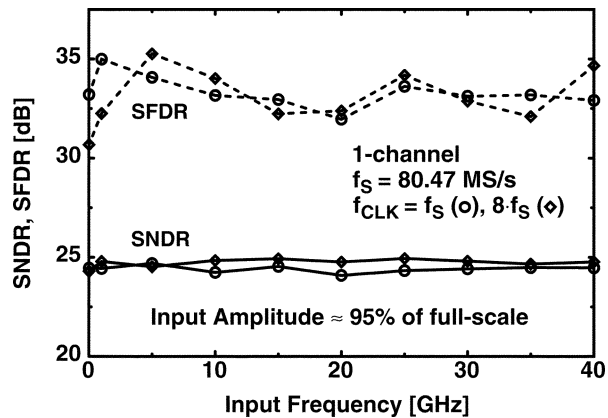


Fig. 18. Measured SNDR and SFDR versus input frequency for single-channel operation.

alias into the Nyquist bandwidth from zero to $f_s/2$, but preserves signal, distortion, and noise power. The spurious-free dynamic range (SFDR) of the A/D converter is determined by dividing the power in the fundamental tone by the power in the largest other tone in the output spectrum, which in this case is the second harmonic, $HD2$. The signal-to-noise-plus-distortion ratio (SNDR) is calculated by dividing the power in the fundamental tone by the total baseband noise and distortion power other than that in the fundamental.

Fig. 18 shows a plot of the SNDR and SFDR measured for operation of a single channel of the A/D converter over an input frequency range from 3 MHz to 40 GHz and at a digital output amplitude of 95% of full-scale. The input to the one-channel A/D converter is optically sampled at $f_s \approx 80$ MS/s. However, the A/D converter performance was evaluated for both $f_{\text{CLK}} \approx 80$ MHz and $f_{\text{CLK}} \approx 640$ MHz. In both cases, the SFDR is limited to about 32 dB (5 bits) by second harmonic distortion in the input buffer amplifier, which is a consequence of the large input common-mode variation that results from capacitive feedthrough in the sampling circuit. The SNDR remains approximately constant with input frequency up to 40 GHz and does not appear to be limited by jitter from the sampling switches, the laser or the input source. The extent to which the measured baseband noise exceeds the quantization noise is assumed to be

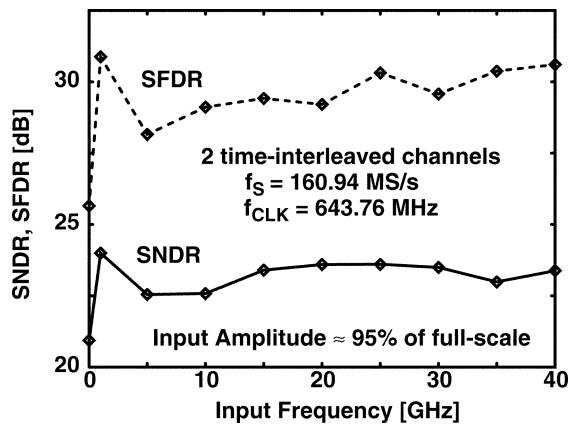


Fig. 19. Measured SNDR and SFDR versus input frequency for operation of two time-interleaved channels.

TABLE I
PERFORMANCE SUMMARY

Technology		1p5m 0.25- μm CMOS
Supply Voltage		2.5 V
A/D Conversion Rate		2×640 MHz
Optical Sampling Rate		2×80 MS/s
Nominal Resolution		4 b
Input Range		560 mV peak-to-peak
Input Bandwidth		3 MHz to 40 GHz
Peak SNDR / SFDR @ $f_{\text{IN}} = 40$ GHz		23.4 dB / 30.6 dB
DNL / INL		0.2 LSB / 0.35 LSB
Area per chan. (excl. drivers)		$150 \times 450 \mu\text{m}^2$
Power per channel:	Analog	40 mW @ $f_{\text{CLK}} = 640$ MHz
	Digital (excl. drivers)	30 mW @ $f_{\text{CLK}} = 640$ MHz
	Optical	~ 4 mW @ $f_{\text{S}} = 80$ MS/s

the result of sampling jitter. If the quantization noise is assumed to have a uniform spectral density, then an upper bound for the sampling jitter of 80-fs can be estimated from the measured signal-to-noise-ratio (SNR). The effective resolution bandwidth of the A/D converter may be significantly higher than 40 GHz, but a higher frequency source was not available.

The measured SFDR and SNDR of the time-interleaved two-channel A/D converter are shown in Fig. 19. The SFDR is again limited by second harmonic distortion that is presumed to occur in the input buffer amplifier. SNDR does not appear to degrade with input frequency, which indicates that the performance is not limited by either sampling jitter or distortion from timing skew between the two channels.

The measured performance of the experimental prototype is summarized in Table I.

VI. CONCLUSION

An optically-triggered sample-and-hold circuit employing LT-grown GaAs MSM switches has been integrated with parallel CMOS A/D converters to demonstrate the feasibility of a wide-bandwidth, time-interleaved photonic A/D converter architecture. The MSM switches provide aperture times of a few picoseconds, with precise sampling times derived from a

low-jitter, short-pulse laser. Each time-interleaved channel samples the electrical input with a pair of MSM switches, one for sampling and a second replica switch for feedthrough cancellation. The differential held signal is quantized by a high-speed CMOS A/D converter in which a low-input-capacitance buffer amplifier rejects input common-mode variations in the held signal and provides a fast-settling output to drive a 4-bit flash quantizer. Resistive offset averaging is applied to an array of regenerative preamplifiers to decrease the input capacitance and power dissipation of the flash quantizer by relaxing transistor matching constraints.

A prototype two-channel A/D converter has been implemented in a 2.5-V, 0.25- μm CMOS technology and integrated with LT-grown GaAs MSM switches using flip-chip bonding. Each A/D converter channel operates at up to a 640-MHz sampling rate, dissipates 70 mW, and occupies an area of $150 \mu\text{m} \times 450 \mu\text{m}$. At an optically-triggered sampling rate of 160 MS/s, the time-interleaved converter achieves greater than 3.5 effective bits of resolution at a 40-GHz input frequency with over 30 dB of SFDR and an estimated sampling jitter of less than 80 fs. The wide input bandwidth, precise timing, low area, and low power suggest the feasibility of integrating a larger number of parallel channels to achieve much higher sampling rates.

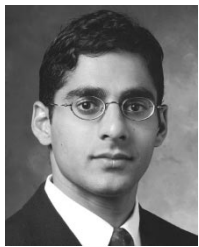
ACKNOWLEDGMENT

The authors thank K. Ma and Prof. J. S. Harris, Jr. for growth of the LT GaAs and National Semiconductor for fabrication of the CMOS circuits.

REFERENCES

- [1] K. Azadet *et al.*, "Equalization and FEC techniques for optical transceivers," *IEEE J. Solid-State Circuits*, vol. 37, pp. 317–327, Mar. 2002.
- [2] K. Poulton *et al.*, "A 20 GS/s 8 b ADC with a 1 MB memory in 0.18 μm CMOS," in *IEEE Int. Solid-State Circuits Conf. Dig. Tech. Papers*, Feb. 2003, pp. 318–319.
- [3] R. H. Walden, "Analog-to-digital converter survey and analysis," *IEEE J. Select. Areas Commun.*, vol. 17, pp. 539–550, Apr. 1999.
- [4] P. W. Juodawlkis *et al.*, "Optically sampled analog-to-digital converters," *IEEE Trans. Microwave Theory Tech.*, pp. 1840–1853, Oct. 2001.
- [5] F. W. Smith *et al.*, "Picosecond GaAs-based photoconductive optoelectronic detectors," *Appl. Phys. Lett.*, vol. 54, no. 10, pp. 890–892, Mar. 1989.
- [6] R. Urata, R. Takahashi, V. A. Sabnis, D. A. B. Miller, and J. S. Harris Jr., "Ultrafast differential sample and hold using low-temperature-grown GaAs MSM for photonic A/D conversion," *IEEE Photon. Technol. Lett.*, vol. 13, pp. 717–719, July 2001.
- [7] W. C. Black Jr. and D. A. Hodges, "Time interleaved converter arrays," *IEEE J. Solid-State Circuits*, vol. SC-15, pp. 1022–1029, Dec. 1980.
- [8] K. Kattmann and J. Barrow, "A technique for reducing differential non-linearity errors in flash A/D converters," in *IEEE Int. Solid-State Circuits Conf. Dig. Tech. Papers*, Feb. 1991, pp. 170–171.
- [9] M. Koyama *et al.*, "A 2.5 V active low-pass filter using all npn Gilbert cells with a $1-V_{\text{D-P}}$ linear input range," *IEEE J. Solid-State Circuits*, vol. 28, pp. 1246–1253, Dec. 1993.
- [10] M. J. M. Pelgrom, A. C. J. Duinmaijer, and A. P. G. Welbers, "Matching properties of MOS transistors," *IEEE J. Solid-State Circuits*, vol. 24, pp. 1433–1440, Oct. 1989.
- [11] K. Bult and A. Buchwald, "An embedded 240-mW 10-b 50-MS/s CMOS ADC in 1- μm^2 ," *IEEE J. Solid-State Circuits*, vol. 32, pp. 1887–1895, Dec. 1997.
- [12] M. Choi and A. A. Abidi, "A 6-b 1.3-Gsample/s A/D converter in 0.35 μm CMOS," *IEEE J. Solid-State Circuits*, vol. 36, pp. 1847–1858, Dec. 2001.

- [13] P. C. S. Scholtens and M. Vertregt, "A 6 b 1.6-Gsample/s flash ADC in 0.18- μ m CMOS using averaging termination," *IEEE J. Solid-State Circuits*, vol. 37, pp. 1599–1609, Dec. 2002.
- [14] D. W. Dobberpuhl, "The design of a high performance low power microprocessor," in *Proc. Int. Symp. Low Power Electronics and Design*, Aug. 1996, pp. 11–16.
- [15] J. Doernberg, H.-S. Lee, and D. A. Hodges, "Full-speed testing of A/D converters," *IEEE J. Solid-State Circuits*, vol. 19, pp. 820–827, Dec. 1984.



Lalitkumar Y. Nathawad (S'93) was born in Windsor, Canada, in 1974. He received the B.A.Sc. degree in engineering physics from Simon Fraser University, Burnaby, BC, Canada, in 1997, and the M.S. degree in electrical engineering from Stanford University, Stanford, CA, in 2000, where he is currently working toward the Ph.D. degree in electrical engineering. His doctoral research focuses on the design of high-speed CMOS analog-to-digital converters.

During the summer of 1998, he interned at Rockwell Semiconductor Systems, Newport Beach, CA, where he investigated base doping profile optimization for SiGe HBT's. In the summer of 2000, he was a circuit design intern at National Semiconductor, Santa Clara, CA, where he worked on a high-bandwidth sample-and-hold circuit for pipeline A/D converters. His research interests are in analog and mixed-signal circuit design for high-speed communications and instrumentation.



Ryohei Urata (S'99) was born in Tokyo, Japan, in 1975. He received the B.S. degree in engineering physics from the University of California at Berkeley in 1997 and the M.S. degree in electrical engineering from Stanford University, Stanford, CA, in 1998. He is currently working toward the Ph.D. degree in electrical engineering under Prof. D. A. B. Miller at Stanford University.

During the summer of 1997, he interned at NTT Photonics Laboratories, Kanagawa, Japan, where he was engaged in semiconductor mode-locked laser research. His research interests are in photonic A/D conversion and high-speed optoelectronics.



Bruce A. Wooley (S'64–M'70–SM'76–F'82) was born in Milwaukee, WI, on October 14, 1943. He received the B.S., M.S., and Ph.D. degrees in electrical engineering from the University of California at Berkeley in 1966, 1968, and 1970, respectively.

From 1970 to 1984, Dr. Wooley was a Member of the Research Staff at Bell Laboratories, Holmdel, NJ. In 1980, he was a Visiting Lecturer at the University of California at Berkeley. In 1984, he joined the faculty at Stanford University, where he is the Robert L. and Audrey S. Hancock Professor of Engineering and the Chairman of the Department of Electrical Engineering. At Stanford, he has also served as the Senior Associate Dean of Engineering and the Director of the Integrated Circuits Laboratory. His research is in the field of integrated circuit design, where his interests include low-power mixed-signal circuit design, oversampling A/D and D/A conversion, circuit design techniques for video and image data acquisition, high-speed embedded memory, high-performance packaging and testing, noise in mixed-signal integrated circuits, and circuits for high-speed communications. He has published more than 130 technical articles and is a coauthor of *The Design of Low-Voltage, Low-Power Sigma-Delta Modulators* (Norwell, MA: Kluwer, 1998). He is a coeditor of *Analog MOS Integrated Circuits, II* (New York: Wiley, 1989).

Dr. Wooley is the Past President of the IEEE Solid-State Circuits Society. He has served as the Editor of the IEEE JOURNAL OF SOLID-STATE CIRCUITS and as the Chairman of both the International Solid-State Circuits Conference (ISSCC) and the Symposium on VLSI Circuits. He is also a Past Chairman of the IEEE Solid-State Circuits and Technology Committee, and he has been a member of the IEEE Solid-State Circuits Society Adcom, the IEEE Solid-State Circuits Council, the IEEE Circuits and Systems Society Adcom, the Executive Committee of the ISSCC, and the Executive Committee of the Symposium on VLSI Circuits. He was awarded the University Medal by the University of California at Berkeley, and he was an IEEE Fortescue Fellow. He was a recipient of the IEEE Third Millennium Medal, and he was recognized for his Outstanding Contributions to the Technical Papers of the International Solid-State Circuits Conference on the occasion of the conference's fiftieth anniversary. He is also a recipient of the Outstanding Alumnus Award from the EECS Department of the University of California at Berkeley.



David A. B. Miller (M'84–SM'89–F'95) received the B.Sc. degree from St. Andrews University, St. Andrews, U.K., and the Ph.D. degree from Heriot-Watt University, Edinburgh, U.K., in 1979.

He was with Bell Laboratories, Holmdel, NJ, from 1981 to 1996, as a Department Head from 1987 of the Advanced Photonics Research Department. He is currently the W. M. Keck Professor of Electrical Engineering at Stanford University, Stanford, CA, and the Director of the Ginzton and Solid State and Photonics Laboratories, Stanford, CA. His research interests

include quantum-well optoelectronic physics and devices, and fundamental and applications of optics in information, sensing, switching, and processing. He has published more than 200 scientific papers, and holds over 40 patents.

Dr. Miller has served as a Board member for both the Optical Society of America (OSA) and IEEE Lasers and Electro-Optics Society (LEOS), and in various other society and conference committees. He was President of the IEEE Lasers and Electro-Optics Society in 1995. He was awarded the Adolph Lomb Medal and the R. W. Wood Prize from the OSA, the International Prize in Optics from the International Commission for Optics, and the IEEE Third Millennium Medal. He is a Fellow of the Royal Societies of London and Edinburgh, OSA, APS, and IEEE, and holds an honorary degree from the Vrije Universiteit Brussel.